

Notice of References Cited	Application/Control No. 10/749,958	Applicant(s)/Patent Under Reexamination DUBIN ET AL.	
	Examiner William T. Leader	Art Unit 1753	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,737,939	05-2004	Hoppe et al.	333/186
*	B	US-6,755,956	06-2004	Lee et al.	205/104
*	C	US-6,919,009	07-2005	Stonas et al.	205/74
*	D	US-7,070,687	07-2006	Chikarmane et al.	205/123
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	John L. Vossen et al, Thin Film Processes, Academic Press, New York, 1978, pp.212-218, 229-231.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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